



Optics Letters

Extending the depth of field for ptychography using complex-valued wavelets: publisher's note

XIAOJING HUANG,^{1,*} HANFEI YAN,¹ IAN K. ROBINSON,^{2,3} AND YONG S. CHU¹

¹National Synchrotron Light Source II, Brookhaven National Laboratory, Upton, New York 11973, USA

²Condensed Matter Physics and Materials Department, Brookhaven National Laboratory, Upton, New York 11973, USA

³London Centre for Nanotechnology, University College London, London, WC1H 0AH, UK

*Corresponding author: xjhuang@bnl.gov

Received 17 January 2019; posted 17 January 2019 (Doc. ID 357998); published 28 January 2019

This publisher's note corrects an error in Eq. (3) of Opt. Lett. 44, 503 (2019). © 2019 Optical Society of America

<https://doi.org/10.1364/OL.44.000662>

In Eq. (3) of [1], -1 was mistakenly changed from superscript to subscript during the production process:

$$I_m = \text{CWT}_{-1}[\{c_j'(n, m)\}_j]. \quad (3)$$

The correct equation is:

$$I_m = \text{CWT}^{-1}[\{c_j^t(n, m)\}_j]. \quad (3)$$

The article was corrected online as of 18 January 2019.

REFERENCE

1. X. Huang, H. Yan, I. K. Robinson, and Y. S. Chu, *Opt. Lett.* **44**, 503 (2019).